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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**PATENT APPLICATION**

In re application of

Docket No: Q79289

Masayuki TAKASHIMA, et al.

Appln. No.: 10/750,971

Group Art Unit: 1751

Confirmation No.: 1869

Examiner: Brian P. Mruk

Filed: January 5, 2004

For: CLEANING SOLUTION FOR SEMICONDUCTOR SUBSTRATE

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month, extending the time for responding to the Office Action of February 7, 2006 to June 7, 2006.

A check for the statutory fee of \$120.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: June 7, 2006

*Jennifer R. Leach*  
Jennifer R. Leach

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